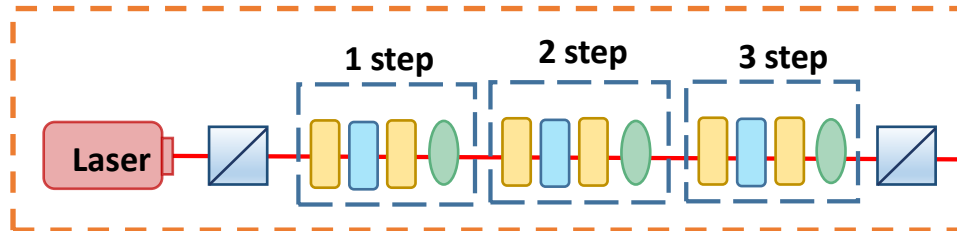


Generation



Optical Elements



Measurement

